



Gases and Facilities Japan Joint TC Chapter Meeting

Friday, December 11, 2020

SEMI Japan office, Tokyo, Japan

13:00–16:00

AGENDA(tentative)

	Time
1 Welcome/Call to Order	00:00
1.1 Introductions	
1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)	
1.3 Agenda Review	
2 Review of Previous Meeting Minutes	00:00
3 Liaison Report	00:00
3.1 Europe TC Chapter	
3.2 NA TC Chapter	
3.3 Korea TC Chapter	
4 Staff Report	00:00
5 Ballot Review	00:00
5.1 6395B - Revision to SEMI F1-0812, Specification for Leak Integrity of High Purity Gas Piping Systems and Components	
6 Subcommittee & Task Force Reports	00:00
6.1 Gases Japan TC Chapter	
6.2 Facilities Japan TC Chapter	
6.2.1 F1 Revision Task Force	
6.2.2 5-year-review Task Force	
7 Old Business	00:00
8 New Business	00:00
8.1 Conduct a simulation of Official Virtual TC Chapter Meeting	
9 Action Item Review	00:00
9.1 Open Action Items	
9.2 New Action Items	
10 Next Meeting and Adjournment	00:00



Time

10.1 The next meeting is scheduled for <date> at <event/location>